

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of )  
)  
Shinichi KAWAMURA et al )  
)  
Serial No.: 09/377,064 ) Group Art Unit: 2766  
)  
Filed: August 19, 1999 ) Examiner: Not Assigned

For: ENCRYPTION/DECRYPTION APPARATUS, ENCRYPTION/DECRYPTION  
METHOD, AND PROGRAM STORAGE MEDIUM THEREFOR

Assistant Commissioner for Patents  
Washington, DC 20231



Sir:

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)**

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), applicants bring to the Examiner's attention the documents listed on attached Form PTO-1449. Copies of the listed documents are attached. Applicants respectfully request that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed within three months of the filing date of the above-referenced application.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.


If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.



By:

  
Richard V. Burguljan  
Reg. No. 31,744

Dated: November 8, 1999

Enclosures  
RVB/FPD/sci